

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Nobuaki TAKAZAWA et al.

Application No.: New U.S. Patent Application

Filed: February 27, 2004

Docket No.: 118845

For: METHOD OF PRODUCTION, METHOD OF INSPECTION, AND METHOD OF USE
OF SCANNING PROBE MICROSCOPE PROBE

PRELIMINARY AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.